

**Search Notes**

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Examiner

William C. Choi

Applicant(s)/Patent under  
Reexamination

YAMADA, KATSU

Art Unit

2873

**SEARCHED**

Class	Subclass	Date	Examiner
359	686-688	5/10/2006	W.C.

**INTERFERENCE SEARCHED**

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**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Reviewed Parent Application: PCT/JP2004/002987	5/10/2006	W.C.
East Search (US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB - SEE ATTACHED)	5/15/2006	W.C.